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PATENT

Attorney Docket: 90738

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

Applicant(s): Satoshi Komiya et al.

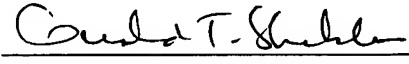
Serial No.: 10/049,971

Filed: October 3, 2003

For: **SILICON WAFER AND METHOD
FOR MANUFACTURE
THEREOF, AND METHOD OF
EVALUATION OF SILICON
WAFER**

Examiner: Not Yet Assigned

Art Unit: 1765

)
) Confirmation No.: 1669
)
) *I hereby certify that this*
) *correspondence is being deposited*
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) *Commissioner for Patents / P.O. Box*
) *1450 / Alexandria, Virginia 22313-*
) *1450, on January 20, 2004*
)
) 
) *Gerald T. Shekleton Reg. No. 27,466*

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Pursuant to 37 C.F.R. §1.97, a list of documents is disclosed on the attached Form PTO-1449 that may be material to the examination of this application.

No inferences should be drawn that the attached list represents a comprehensive investigation, or that any material disclosed is equivalent to the subject invention. In addition, none of the documents that have publication dates prior to the priority date of the above application anticipate the invention in this application.

The cited document(s) disclose numerous specific features. There has been no attempt to list each and every feature disclosed by each document. The Examiner is requested to review the document(s) and determine the extent of the materiality of the document disclosures with respect to the present invention.

The discussion of any art and the citation of any document(s) herein is not to be construed



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as an admission that the art or document disclosure is necessarily within the invention field of endeavor, that the art or document disclosure is necessarily prior in time to a particular date which may be relevant to the instant patent application, and/or that the art or document disclosure is otherwise necessarily prior art as defined by the patent law with respect to the instant invention and application.

Also, there is reserved the right to later set forth how the instant invention is distinguished over the disclosure of any document or other art, including the disclosures of the art and document(s) recited herein, that may be cited by the Examiner in rejecting a claim in the instant patent application. The recitation herein of the art and document(s) is not to be construed as an assertion that more pertinent art could not possibly be in existence.

Respectfully submitted,

WELSH & KATZ, LTD.

Gerald T. Shekleton
Registration No. 27,466

Dated: January 20, 2004

Welsh & Katz, Ltd.

120 South Riverside Plaza, 22nd Floor
Chicago, Illinois 60606
Telephone: 312/655-1500



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Sheet 1 of 1

(Rev. 5/92) Comparable to Form PTO-1449 INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)	U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No. 90738	Serial No. 10/049,971
	Applicant Satoshi Komiya et al.		
	Filing Date October 3, 2003	Group 1765	

U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate

FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Name of Patentee	Class	Subclass	Translation Yes No
		JP 2000-211995	08/02/2000	Shin Etsu Handotai Co., Ltd.			Abs

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							

Examiner	Date Considered
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*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.